

Vacuum Systems Lecture 5

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Outline

- 1. Beam-gas interactions
 - 2. Pressure profiles
 - 3. The LHC case
- 4. Some studies related to LHC, HL-LHC, FCC etc. vacuum systems

1. Beam-gas interactions

Cross section

• The cross section σ , is the probability the beam interacts with the atoms of target

• When a beam of intensity I, cross a target of thickness dx with a density of atoms n, the change in beam current is:

$$dI = -I \sigma n dx$$

- The cross section is a constant having the dimension of an area
- The unit is 1 barn = 10^{-28} m² = 10^{-24} cm²
- The beam moves at a speed v, thus the thickness of target traversed during the time dt equals: v dt
- using the previous equation, this gives:

$$\frac{dI}{dt} = -I \, n \, v \, \sigma$$

Beam residual gas interactions, SP Møller, CAS, CERN 99-05 Lifetime, cross-section and activation, P. Grasfström, CAS, CERN 2007-003



area σ

I particles per cm² n atoms per cm³

Life time

• The evolution of the beam current is given by the integration of the previous equation:

$$I = I_o e^{-\frac{t}{\tau}} \qquad \text{with} \qquad \tau = \frac{1}{n \sigma v}$$

- During the interaction process, the beam current decrease exponentially with a time constant inversely proportional to the gas density and the cross section
- In a vacuum system, the beams interacted differently with the different gas species of density n_i according to their respective cross sections σ_i :

$$\tau_i = \frac{1}{n_i \; \sigma_i \; v}$$

Summing up the interaction process on the different gas species gives:

$$\sum \frac{dI_i}{dt} = -Iv \sum n_i \sigma_i$$

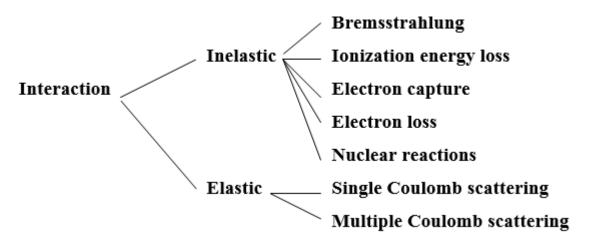
Thus:

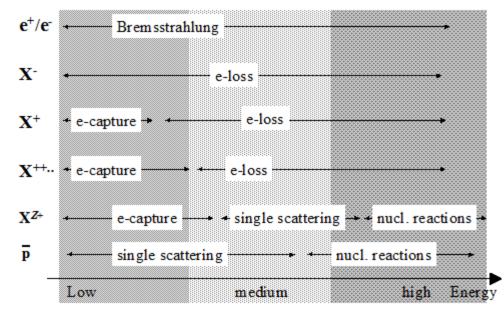
$$\frac{1}{\tau} = \sum \frac{1}{\tau_i}$$

$$\frac{1}{\tau} = \sum \frac{1}{\tau_i}$$
 For a vacuum system:
$$\frac{1}{\tau} = \frac{1}{\tau_{H2}} + \frac{1}{\tau_{CH4}} + \frac{1}{\tau_{H2O}} + \frac{1}{\tau_{CO}} + \frac{1}{\tau_{CO2}}$$

The vacuum life time must be much larger (i.e. >> 24 h) than other life times such as e.g. the particle loss due to the collisions

Beam-gas interactions





Beam residual gas interactions, SP Møller, CAS, CERN 99-05



Proton storage ring

- At high energy, the proton beam can interact with the nuclei of the atom. The scattered proton change its direction or loses so much energy that it is lost from the beam
- The nuclear scattering cross section increases with beam energy: 7 TeV values

Gas	Α	σ(mb)	$\sigma_{rel,i}$
H ₂	2	95	1
He	2	126	1.33
CH ₄	16	566	5.96
H ₂ O	18	565	5.96
CO	28	854	8.99
No	14	820	8.63

924

1317

2177

3231

9.73

13.86

22.92

34.01

32

44

84

131

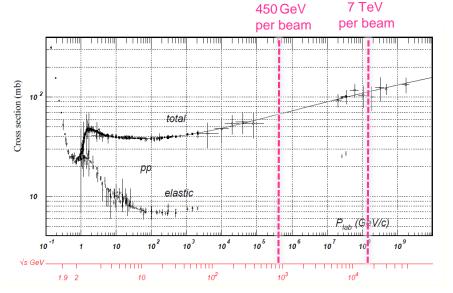
 CO_2

Kr

Xe

$\sigma_{rel,i} =$	$\frac{\sigma_i}{\sigma_{H2}}$
$\sigma_{pA} = c$	$\sigma_{pp}A^{0.7}$

Н	σ(mb)
450 GeV	32.5
7 TeV	47.5
50 TeV	65



Total and elastic cross sections for pp collisions as a function of laboratory beam momentum and total centre of mass energy

• In a vacuum system, it is convenient to express the gas density in H₂ equivalent as if there were one specie of gas.

$$n_{H2\;eq} = \sum n_i\;\sigma_{rel,i}$$

Application: LHC vacuum life time

- In the LHC, the vacuum life time is defined by nuclear scattering set to 100 h:
 - The corresponding H₂ gas density is:

$$n_{H2} = \frac{1}{\tau \, \sigma_{H2} \, c} = \frac{1}{3.6 \, 10^5 \, x \, 95 \, 10^{-31} \, x \, 3 \, 10^8} = 10^{15} \, H_2 \, m^{-3}$$

- *i.e.* 4 10⁻⁸ mbar
- Assuming the residual gas composition is dominated by CO, this would correspond to:

$$n_{CO} = \frac{n_{H2}}{\sigma_{reli}} = \frac{10^{15}}{8.99} = 10^{14} \ CO. m^{-3}$$

- *i.e.* 4 10⁻⁹ mbar
- Assume a gas mixture of H₂ and CO, with 2 10¹⁴ H₂.m⁻³ and 5 10¹³ CO.m⁻³ *i.e.* a total pressure of 10⁻⁸ mbar, what would be the vacuum life time?
 - compute the equivalent H2 gas density:

$$n_{H2\ eq} = n_{H2} + n_{CO}\ \sigma_{rel,co} = 2\ 10^{14} + 8.99\ \times 5\ 10^{13} = 6.4\ 10^{14}$$

• compute the vacuum life time:

$$\tau = \frac{1}{3600} \frac{1}{n_{H2eq} \sigma_{H2} c} = \frac{1}{3600} \frac{1}{6.4 \cdot 10^{14} \cdot x \cdot 95 \cdot 10^{-31} \cdot x \cdot 3 \cdot 10^{8}} = 150 \ h$$



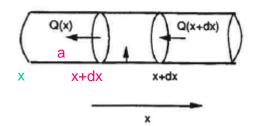
2. Pressure profiles

Gas flow in an elemental chamber

- We assume an elemental vacuum chamber pipe of length dx, with specific conductance c, into which gas desorbs at a rate a.
- The gas flow, Q, through the elemental chamber is:

VACUUM CHAMBER

$$Q = -c \, \frac{dP}{dx}$$



• The change of gas density in the volume element Vdx between x and x+dx is:

$$Vdx\frac{dP}{dt} = +adx + c\left[\frac{dP}{dx}\right]_{x+dx} - c\left[\frac{dP}{dx}\right]_{x}$$

$$V\frac{dP}{dt} = a + c \left[\frac{d^2P}{dx^2} \right]$$

• In steady state condition (dP/dt =0), we have:

$$\frac{d^2P}{dx^2} = -\frac{a}{c}$$

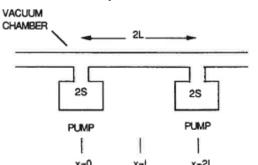
Which solution is a parabolic function.

Vacuum system design, A.G. Mathewson, CAS, CERN 94-041



Simple machine

• We assume a simple machine with pumps of speed 2S, regularly spaced by a distance 2L.



boundary conditions:

$$\left[\frac{dP}{dx}\right]_{x=L} = 0$$
 and $P(0) = P(L) = \frac{a L}{S}$

So:

$$P(x) = \frac{aL}{S} + \frac{aL}{c}x - \frac{a}{2c}x^2$$

• The maximum pressure is given by:

$$P_{max} = \frac{aL}{S} + \frac{aL^2}{2c}$$

The average pressure is given by:

$$P_{av} = \frac{1}{2L} \int_{0}^{2L} P(x) dx = aL \left[\frac{1}{S} + \frac{L}{3c} \right]$$

Vacuum system design, A.G. Mathewson, CAS, CERN 94-041



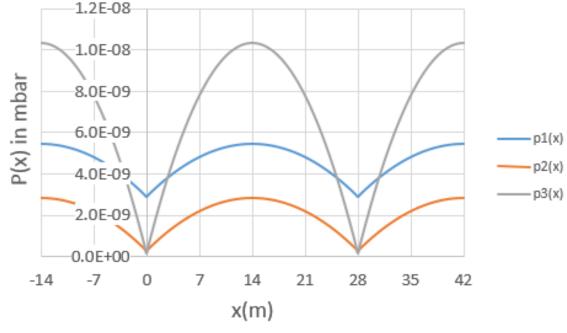
Simple machine: application

- P is the gas pressure (mbar)
- V is the volume per unit of length (I m⁻¹)
- c is the specific conductance of the tube (I s⁻¹ m)

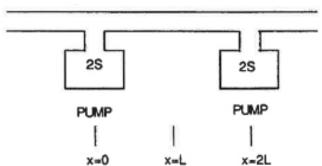
 a is the gas desorption per unit length of tube (mbar I s⁻¹ m 	• a	is the gas	desorption	per unit	length	of tube	(mbar l	S ⁻¹	m
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- 2L is the distance between the pumps (m)
- 2S is the pumping speed (I s⁻¹)

	P1(x)	P2(x)	P(3)
D (cm)	10	10	5
c (I s ⁻¹ m)	121	121	15.1
2S (I s ⁻¹)	30	300	300
P _{max} (mbar)	6 10-9	3 10-9	1 10-8
P _{av} (mbar)	3 10-9	2 10-9	7 10-9



The average pressure is dominated by the conductance





Simple machine with distributed pumping, s

$$V\frac{dP}{dt} = a + (b - s)P + C\frac{d^2P}{dx^2}$$

Where:

a is the linear outgassing rate (includes thermal desorption and photon stimulated desorption) in Torr.l/s/m

s is the linear pumping speed in I/s/m

b is the ion induced desorption; $b = 10^3 \, \eta \sigma I/e$ in I/s/m

I is the proton beam current in A

C is the specific conductance of the vacuum chamber in l.m/s

V is the volume per unit of length in I/m

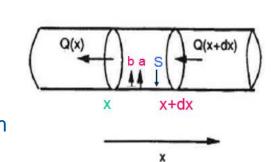
• In quasi static conditions:

$$\frac{d^2P}{dx^2} = \left(\frac{s-b}{C}\right)P - \frac{a}{C}$$

• For long tubes $Cd^2P/dx^2 = 0$:

$$P_{inf} = \frac{a}{s - b}$$

• So the vacuum system is stable if s-b>0 *i.e.* s>b



VACUUM CHAMBER

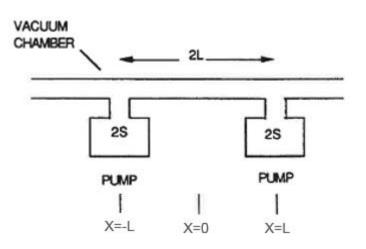
Simple machine with distributed pumping, s

• For short tubes Cd²P/dx² ≠ 0 :

$$P(x) = Ae^{-\lambda x} + Be^{\lambda x} + \frac{a}{\lambda^2 C}$$
 with $\lambda^2 = \frac{s - b}{C}$

With the following boundary conditions:

$$C\left[\frac{dP}{dx}\right]_{x=\mp L} = +/-P(\mp L) 2S$$



• It gives:

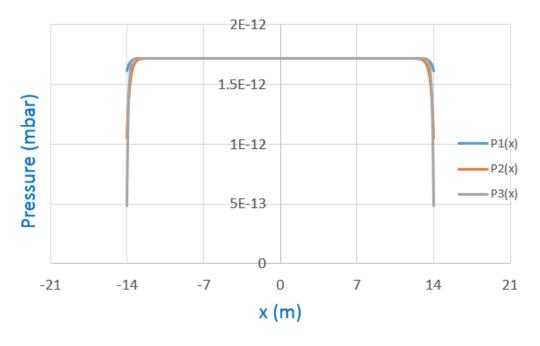
$$P(x) = P_{inf} \left(1 - \frac{\cosh(\lambda x)}{\cosh(\lambda L) \left(1 + \frac{C}{2S} \lambda \tanh(\lambda L) \right)} \right)$$

Simple machine with distributed pumping: application

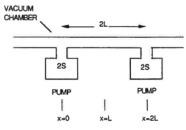
- P is the gas pressure (mbar)
- V is the volume per unit of length (I m⁻¹)
- c is the specific conductance of the tube (I s⁻¹ m)
- b is set to zero

- a is the gas desorption per unit length of tube (mbar I s⁻¹ m⁻¹)
- 2L is the distance between the pumps (m)
- 2S is the pumping speed (I s⁻¹)

	P1(x)	P2(x)	P(3)
D (cm)	10	10	5
c (I s ⁻¹ m)	121	121	15.1
2S (I s ⁻¹)	30	300	300
a (mbar I /s / m)	3 10-9	3 10-9	1.5 10 ⁻⁹
S (I s ⁻¹ m ⁻¹)	1834	1834	917
P _{inf} (mbar)	2 10-12	2 10-12	2 10-12

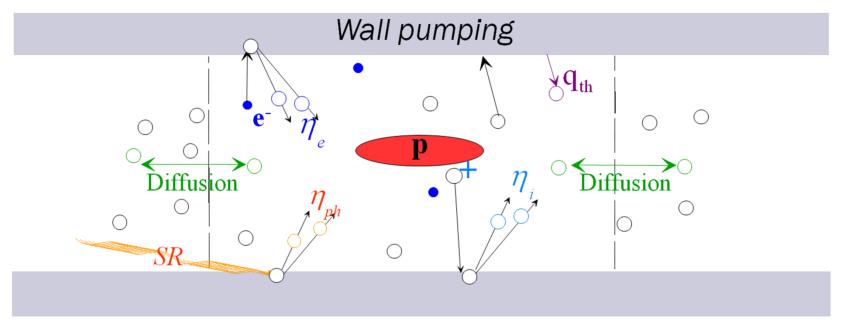


 50 cm away from the pump, the pressure is independent of its pumping speed The average pressure is dominated by the long tube pressure P_{inf}





VASCO: a code to study vacuum stability



_____dx____

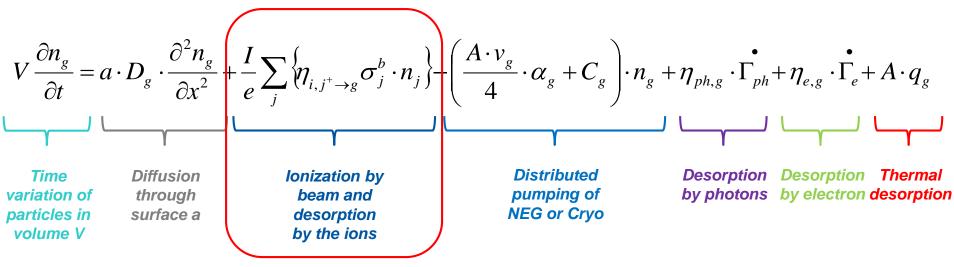
The changing rate of the number of molecules per unit volume:

- Molecular diffusion
- Beam induced dynamic effects: <u>ion</u>, <u>electron</u> and <u>photon</u> induced molecular desorption.
- Gas pumping distributed along the beam pipe: NEG and Cryo
- Gas lumped pumping: Sputtered ion pumps



Gas Balance Equation

VASCO: Multi-gas code to calculate gas density profile in uhv system, A. Rossi. CERN LHC Project Note 341, 2004

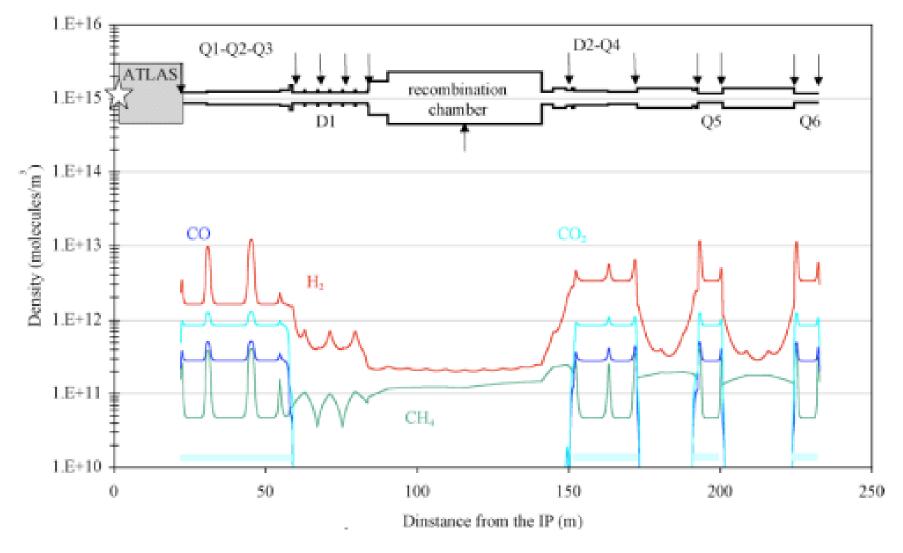


Multi Gas Model

MULTI GAS MODEL

- Dominant gas species present in a vacuum system: H₂, CH₄, CO and CO₂
- The "multi gas" model takes into account that each of the gas species, once ionized, can desorbs any species both from the wall beam pipes or the condensed gas layer in a cryogenic system
- The equation of each species depends on the gas densities of other species, and all the equations results inter-dependent

Gas density profile around ATLAS

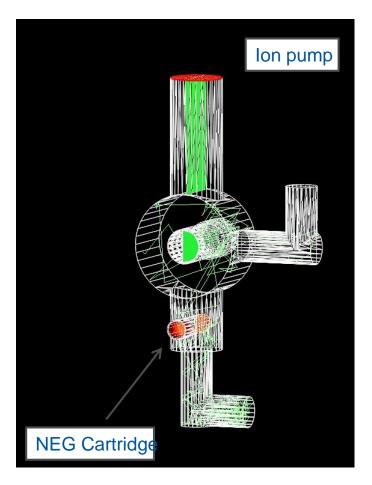


A. Rossi, CERN LHC PR 783, 2004.



Gas density profile simulation: Molflow+

A Test-Particle Monte-Carlo Simulator for Ultra-High Vacuum systems



Simulation done with a flow of 1x10⁻⁸ mbar*l/s coming from the VAX insert

	Pressure in the beam line [mbar]	Pressure in the SVT gauge [mbar]
Ion Pump	2x10 ⁻⁸	2x10 ⁻⁸
Ion Pump + D400 NEG cartridge	6x10 ⁻⁹	6x10 ⁻⁹

Data from G.Bregliozzi – TE-VSC

For info: http://test-molflow.web.cern.ch/content/about-molflow

3. The LHC case

3.1 Design

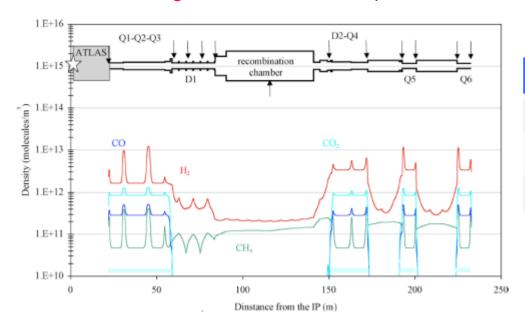
Design value: a challenge with circulating beams

- Life time limit due to nuclear scattering ~ 100 h
 - n ~ 10^{15} H₂/m³
 - <P_{arc}> < 10⁻⁸ mbar H₂ equivalent
 - ~ 80 mW/m heat load in the cold mass due to proton scattering

$$\tau = \frac{1}{\sigma \, c \, n}$$

$$P_{cold\,mass} = \frac{IE}{c\tau}$$

Minimise background to the LHC experiments



	H2_eq / m3	mbar
<lss<sub>1 or 5></lss<sub>	~ 5 10 ¹²	10-10
<atlas></atlas>	~ 10 ¹¹	10-11
<cms></cms>	~ 5 10 ¹²	10-10

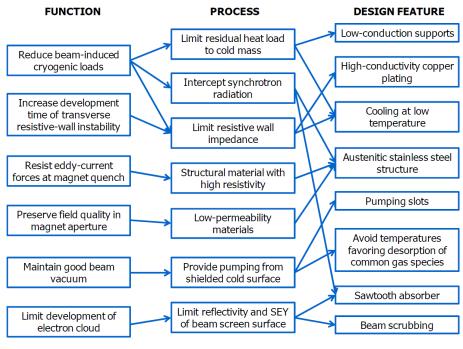
A. Rossi, CERN LHC PR 783, 2004.

New System: LHC Beam Screens Functionalities

- An innovative and complex system, produced at several 10 km scale!
- Intercept the heat load induced by the circulating beam
- Operate between 5 and 20 K
- Pumping holes to control the gas density

Pumping slot shields Pumping slots Cooling tubes Longitudinal weld Beam screen tube Sliding ring "saw teeth"

Functional design map of beam screen



Courtesy N. Kos CERN TE/VSC

P. Lebrun et al.



Why Perforated Beam Screen?

SSC studies in 1994

V.V. Anashin et al. J. Vac. Sci. Technol. A. 12(5), Sep/Oct 194

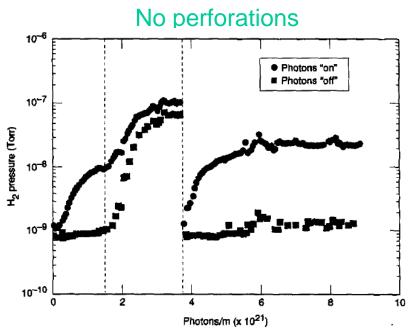


Fig. 1. Room-temperature RGA H₂ pressure measured at the center of the 4.2-K beam tube vs integrated photon flux with photons on and photons off. The raw pressure difference "on" minus "off" has been normalized to 1×10¹⁶ photons/m/s. The vertical dashed lines correspond to features discussed in the text.

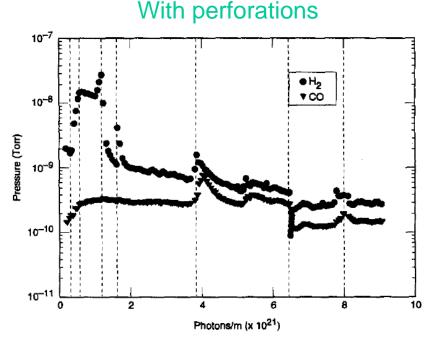


Fig. 2. Room-temperature RGA H2 and CO dynamic pressures measured at the center of the liner configuration. Dynamic pressure is normalized to 1×1016 photons/m/s.

A **perforated** beam screen allows to control the gas density



Gas density & surface coverage equations

V.V. Anashin et al. J. Vac. Sci. Technol. A. 12(5), Sep/Oct 194

$$A \frac{\partial \Theta}{\partial t} = \sigma S n - \eta' \dot{\Gamma} - \frac{A \Theta}{\tau}$$

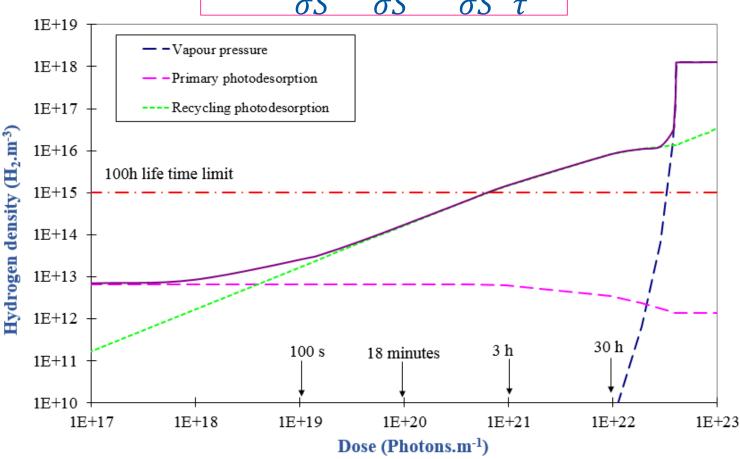
• with:

n gas density, s surface coverage, V volume per unit length, A surface per unit length, A_cD axial diffusion term of molecules, σ sticking probability, S ideal speed per unit length, C beam screen holes pumping speed per unit length, τ sojourn time of physisorbed molecule, η desorption yield of chemisorbed molecules, η recycling desorption yield of physisorbed molecules,

Cryosorbing tube without holes

- Infinitely long tube (A_cD=0), without beam screen (C=0) and quasi static conditions:
- → Three terms adds: primary, recycling desorption and vapour pressure

$$n = \frac{\eta \dot{\Gamma}}{\sigma S} + \frac{\eta' \dot{\Gamma}}{\sigma S} + \frac{1}{\sigma S} \frac{A\Theta}{\tau}$$

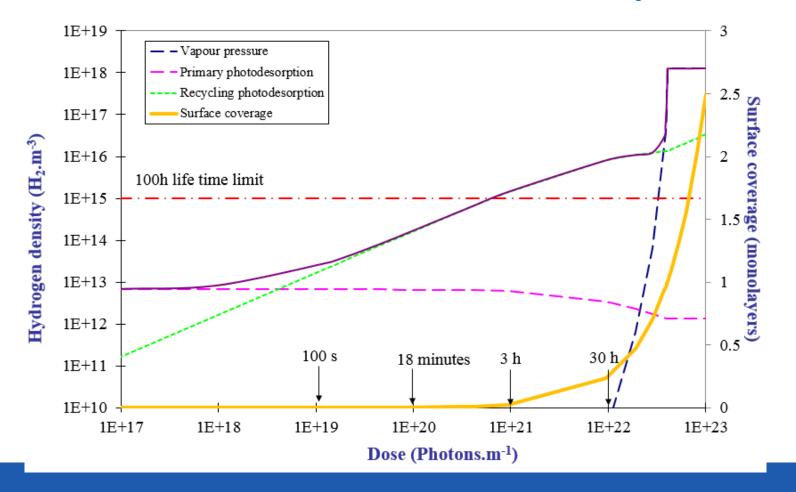


Cryosorbing tube without holes

$$n = \frac{\eta \dot{\Gamma}}{\sigma S} + \frac{\eta'(\Theta) \dot{\Gamma}}{\sigma S} + \frac{1}{\sigma S} \frac{A\Theta}{\tau}$$

Increase with the surface coverage, Θ

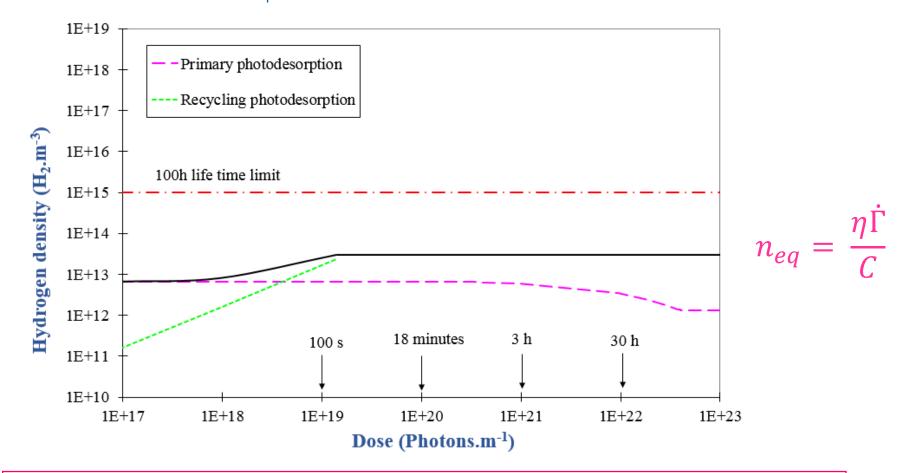
$$\Theta = \frac{1}{A} \int_0^{\Gamma} \eta d\Gamma$$





Perforated beam screen

- Infinitely long tube (A_cD=0), with a beam screen (C=0) and quasi static conditions:
 - The equilibrium pressure n_{eq} is defined by the perforation conductance

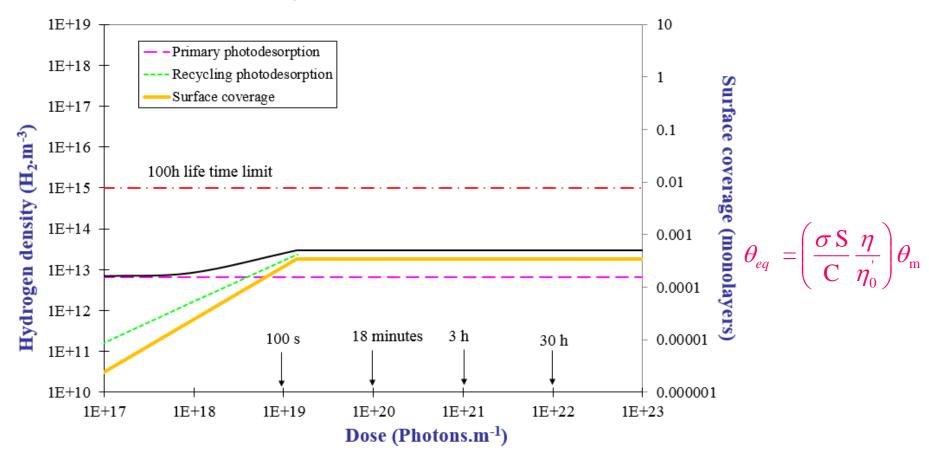


A **perforated** beam screen allows to control the gas density



Perforated beam screen

- Infinitely long tube (A_cD=0), with a beam screen (C=0) and quasi static conditions:
 - The equilibrium coverage is a fraction of a monolayer

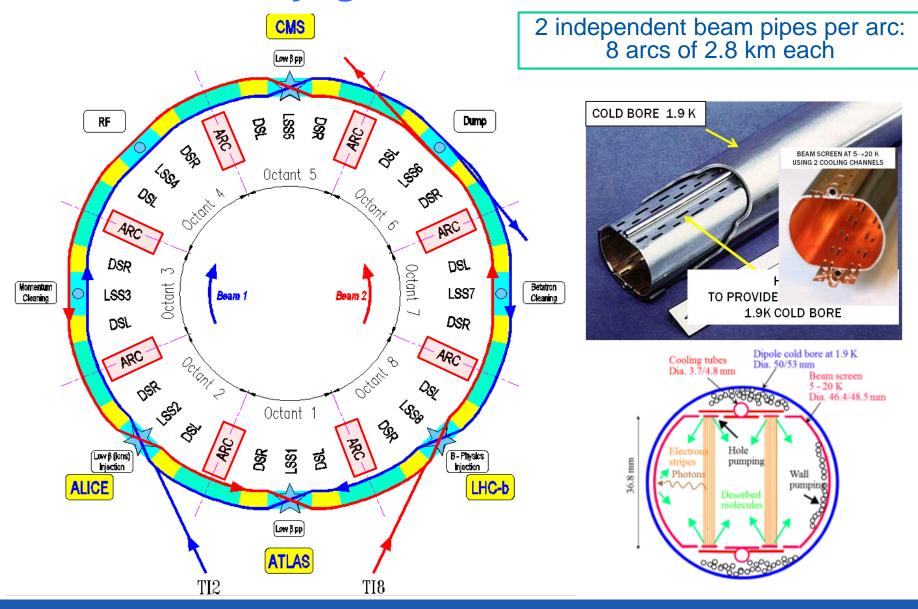


A **perforated** beam screen allows to control the surface coverage



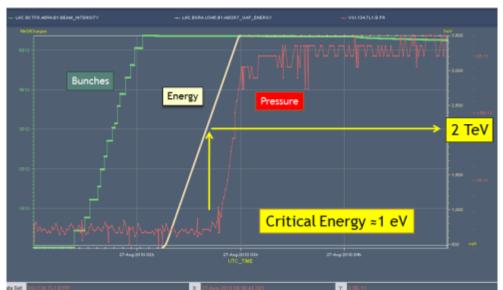
3.2 Arc Vacuum System

Cryogenic Beam Vacuum



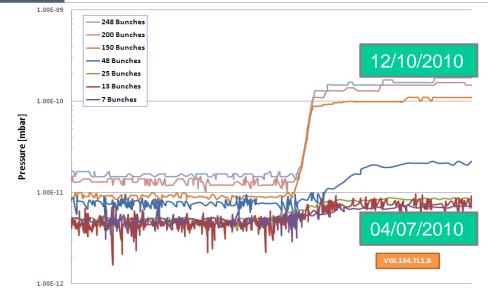


First Observation of Synchrotron Radiation: Aug-2010



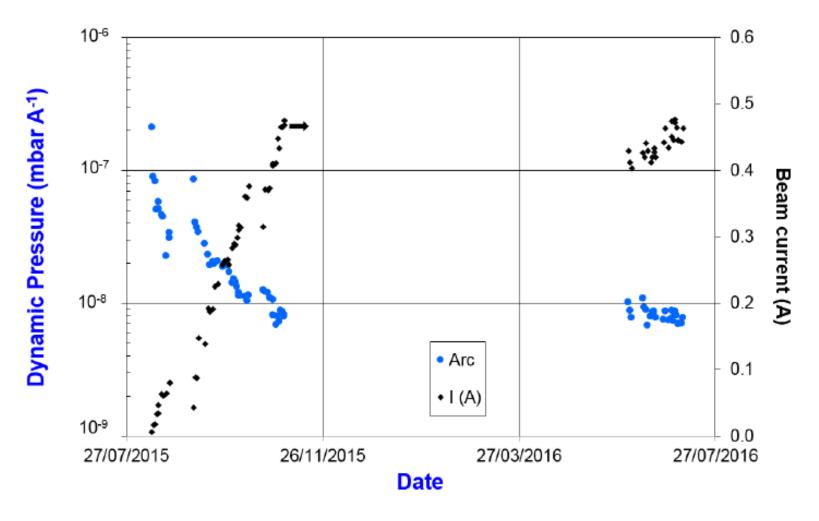
- Pressure rise during the beam energy ramp
- At E= 2 TeV, Critical energy 1 eV, pressure starts to rise

- Dynamic pressure increases with beam current
- DeltaP = 2 10⁻¹⁰ mbar



Beam conditioning in the LHC arcs

Dynamic pressure reduction during LHC commissioning.

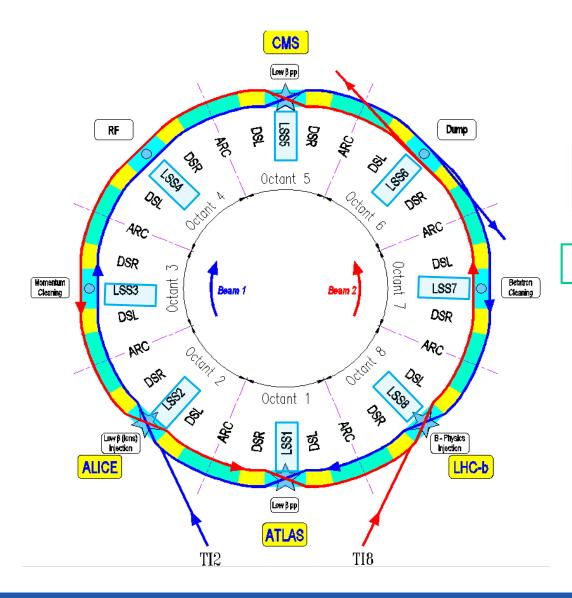


V. Baglin, Vacuum, 2016



3.3 RT Vacuum System

Room Temperature Beam Vacuum



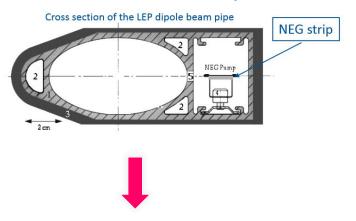
6 km of RT beam vacuum in the long straight sections

Extensive use of NEG coatings

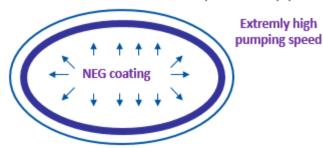
Pressure <10⁻¹¹ mbar after vacuum activation

New System: NEG film coating

- Invention of low activation temperature getter film
 => full pumping across the beam pipe
- Some vacuum chambers were constructed and getter coated ...
- ~ 1 200 vacuum chambers produced



Cross section of an LHC warm dipole beam pipe



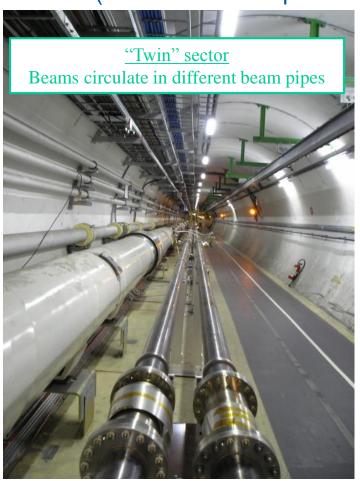
C. Benvenuti et al.



Courtesy R. Veness and P. Chiggiato

Room Temperature Vacuum System

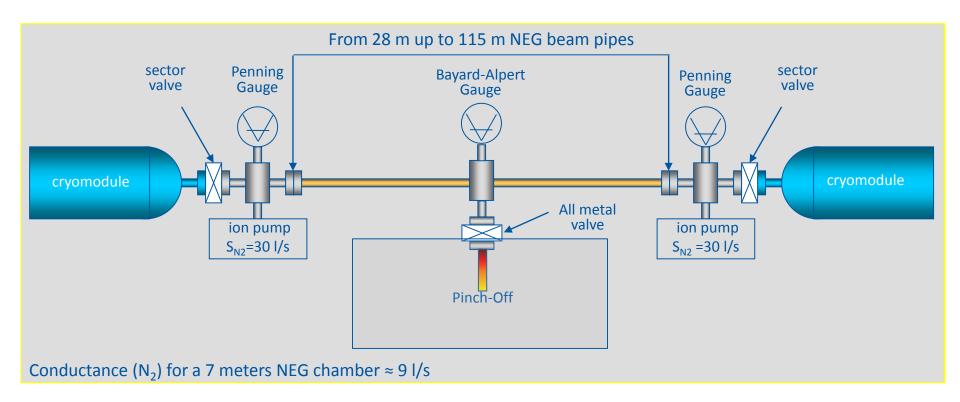
- and installed inside the LHC tunnel
- to bring the separated beams from the arcs into a single beam pipe for the experiments (held at room temperature!)





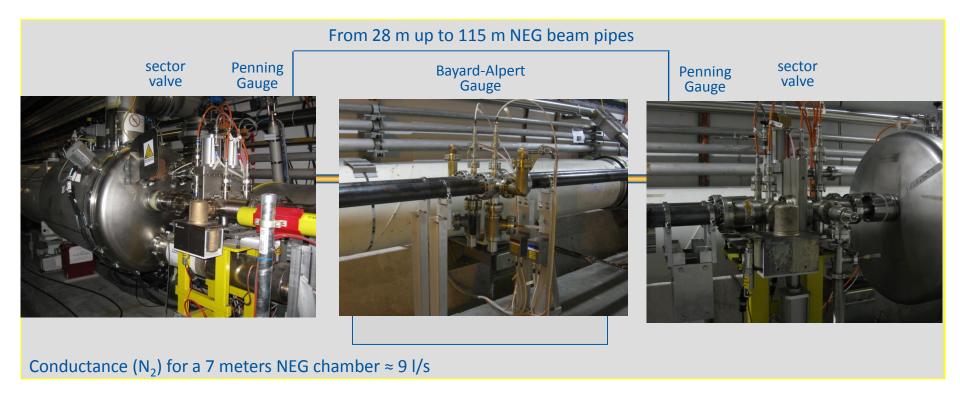
Room Temperature Vacuum Sectors

- 185 vacuum sectors at RT
- From 1 m till 150 m long
- Contains: kickers, septum, collimators, masks, beam instrumentation
- Separation of baked from cryogenic unbaked vacuum sectors



Room Temperature Vacuum Sectors

- 185 vacuum sectors at RT
- From 1 m till 150 m long
- Contains: kickers, septum, collimators, masks, beam instrumentation
- Separation of baked from cryogenic unbaked vacuum sectors

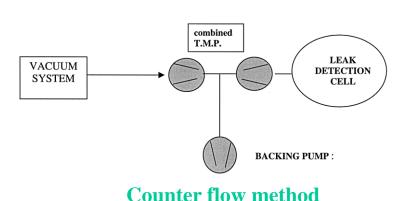


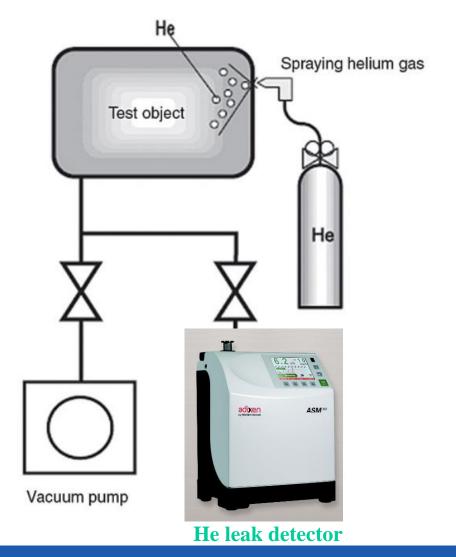
Principle of leak detection

• Detection method: He is sprayed around the test piece and a helium leak detector (*i.e.* a RGA tune to He signal) is connected to the device under test.

Design in LHC:

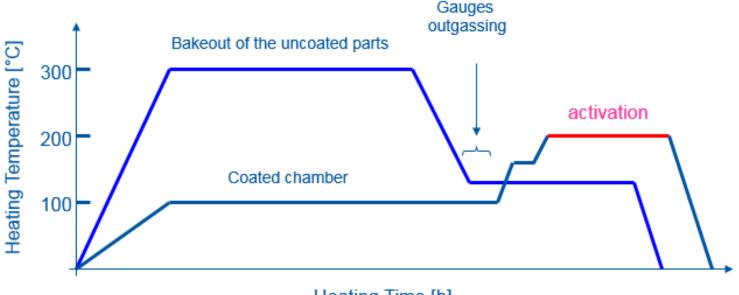
leak rate < 10⁻⁹ mbar.l/s for a vacuum sector so the leak rate per component < 10⁻¹⁰ mbar.l/s







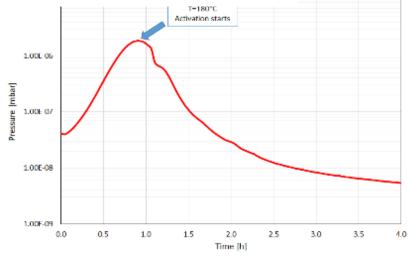
Commissioning of the NEG coated vacuum system



Courtesy G. Bregliozzi, P. Chiggiato

Heating Time [h]

- Bake out of stainless steel part first
- Followed by NEG activation at ~ 200 °C
- Acceptance criteria rely on :
 - Temperature monitoring during activation
 - Aperture pumping speed measurement
 - Residual gas analysis
 - Leak rate below ~ 10⁻⁹ mbar.l/s

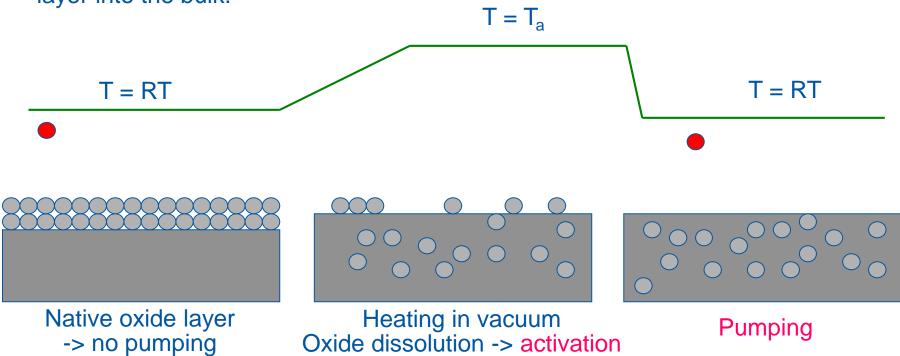


Courtesy G. Bregliozzi, V. Bencini



Non-Evaporable Getter (NEG)

Getters are materials capable of chemically adsorbing gas molecules. To do so
their surface must be clean. For Non-Evaporable Getters a clean surface is
obtained by heating to a temperature high enough to dissolve the native oxide
layer into the bulk.



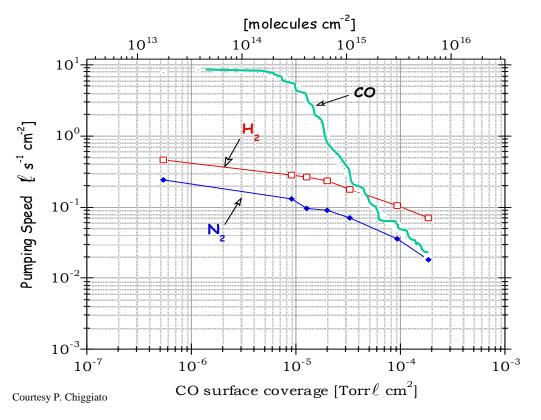
NEGs pump most of the gas except rare gases and methane at room temperature

P. Chiggiato and P. Costa Pinto, Thin Solid Films, 515 (2006) 382-388



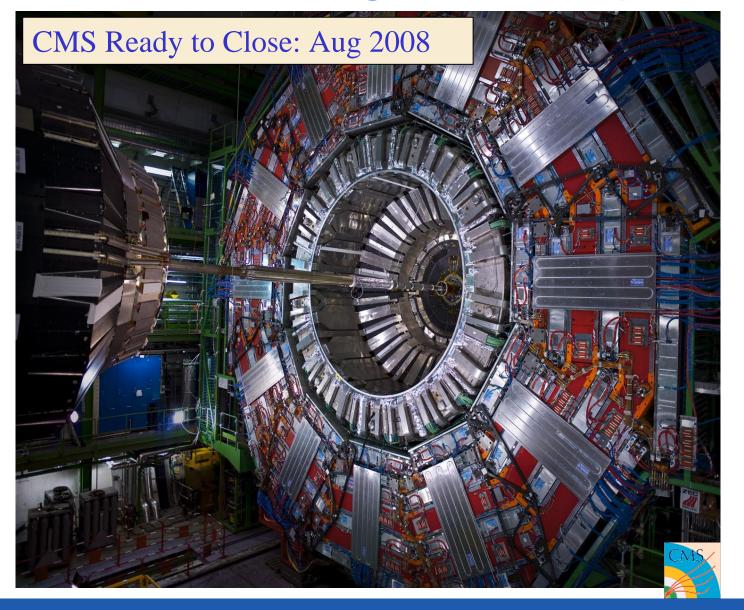
TiZrV Vacuum Performances

Pumping Speed



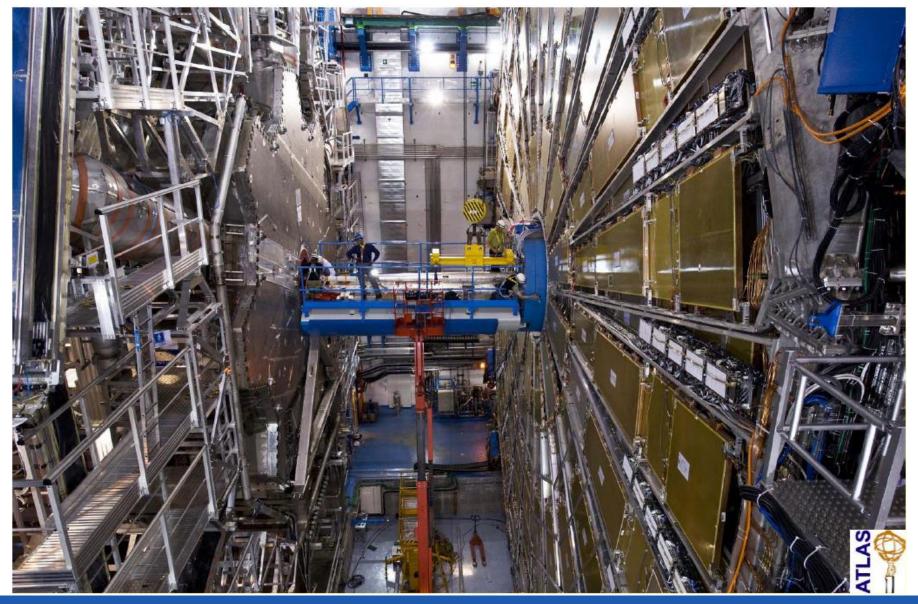
- Very large pumping speed : ~ 250 l/s/m for H₂, 20 000 l/s.m for CO
- Very low outgassing rate
- But : limited capacity and fragile coating sensitive to pollutant (hydrocarbons, Fluor ...)

And of Course ... Through the LHC Experiments





Beam Pipe Installation in ATLAS Before Closure



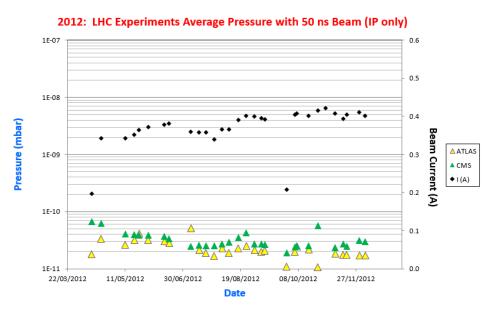


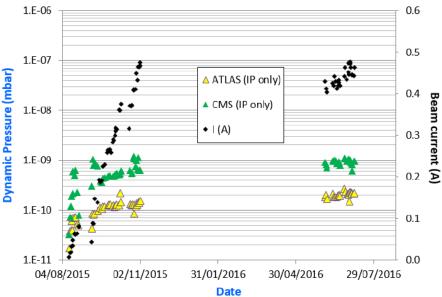
LHC Experimental Areas

- NEG coated vacuum system
 - => Large pumping speeds, low SEY and desorption yields
 - <P_{LHC Experiments} > ~ 5 10⁻¹⁰ mbar => with 25 ns bunch spacing and 450 mA

 - => No background issues: within specifications
 - <P_{LHC Experiments} > with 50 ns beams
 - ~ 5 10⁻¹⁰ mbar in 2011 at 375 mA
 - $\sim 3 \cdot 10^{-11}$ mbar in 2012 at 400 mA

 <P_{LHC Experiments} > with 25 ns beams $\sim 5 \cdot 10^{-10}$ mbar in at 450 mA and 25 ns bunch spacing



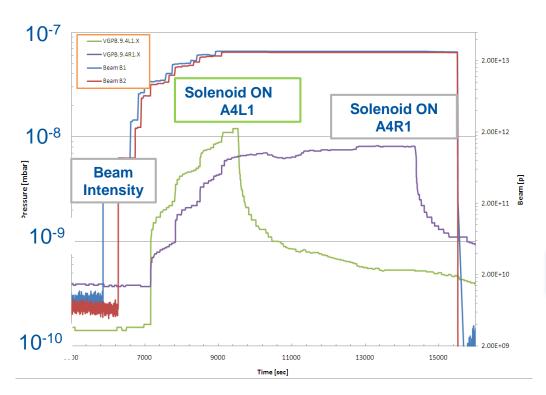


V. Baglin., Vacuum 138 (2017) 112-119



First Observation of Electron Cloud: 29-9-2010

- The position at 45 m from the IP is the longest unbaked area (operating at RT) in LHC, so the first candidate to trigger electron cloud
- Reduction of 1 order of magnitude when solenoids are ON



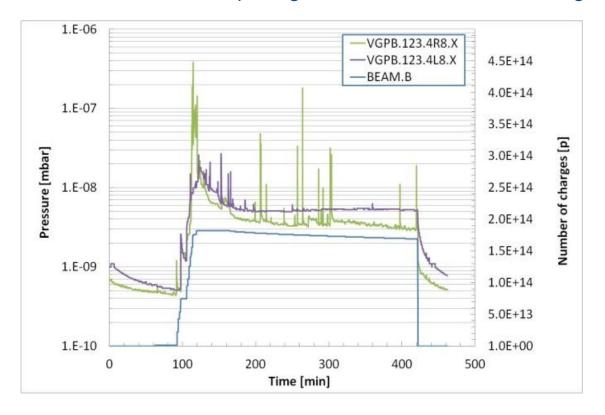


G. Bregliozzi et al., IPAC San Sebastian, 2011



Appropriate mechanical design is vital

- Design extrapolated and not mechanically validated before installation in the ring
- Pressure spikes located beside inner triplets generated interlocks and background



Observed Pressure spikes during a physics fill

Vacuum Modules or what can you do with beam heating

- X-rays done in May showed a conform module, in November the module was broken
- The RF bridge was destroyed by the beam!
- 8 out of a total of 20 in LHC were damaged i.e. 40 %

Typical default, DCUM 3259.3524

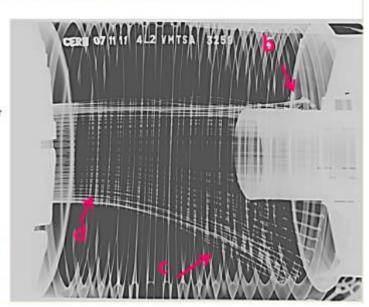
Left side

Side view (xray from corridor to QRL)

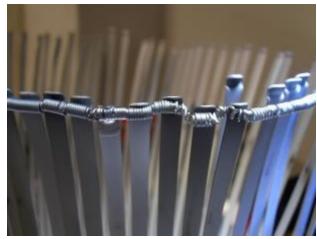
- b) Metallic noise due to loose spring when hitting vacuum chamber
- c) RF fingers falling due to broken spring
- d) aperture reduced ?

Non Conform

Spring was broken between May and November 2011









QQBI.26R7 line V2





Typical default, DCUM 3259,3524 Side view brzy from comidor to (1911) b) Mutalic no se due to loose spring when nitting veguan chamber d RESistent Nilhe du to broken spring if aperture reduces ? Non Conform Spring was broken between May and November 2011









Iany poportunities

Using
to calculate the calculation of the calculat



















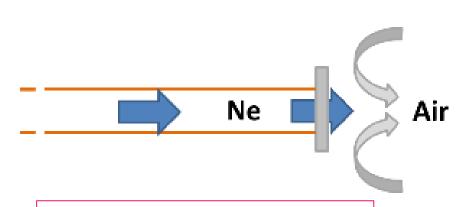
A13L4.V1

QBQI 12L4.V1



Fast Repair: Ne venting

- 5 days intervention
- Ne flow to reduce air back streaming
- This method avoids the NEG saturation (remember Ne is an inert gas).



The new piece/chamber will need **conditioning**:

→ temporary local pressure rise when a new piece is installed



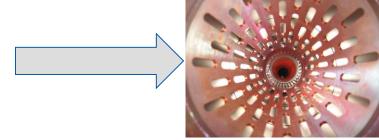
Neon trolley

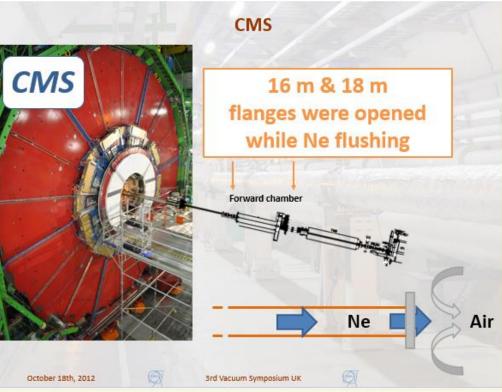
Ne venting to save the 2012 CMS Run!

Vacuum system performance recovered even following the dismounting of 2 m long

vacuum chambers









January 2012



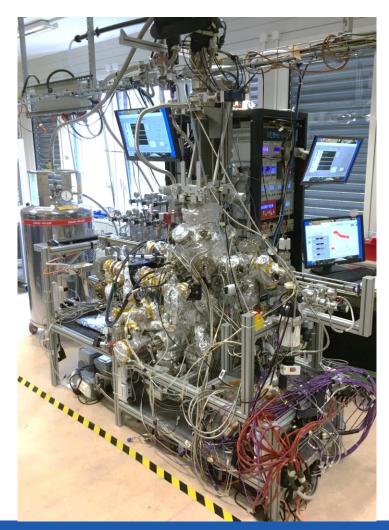
4. Some studies related to LHC, HL-LHC, FCC etc. Vacuum systems

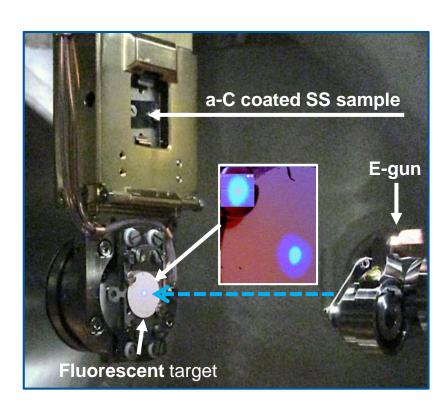
Laboratory

Studies at cryogenic temperature down to 10 K

• Isotherm, TDS, sticking coefficient, beam induced desorption from electrons, ions

etc.





LHC Vacuum pilot sector

- Total and partial pressure, photoelectron current, electron cloud flux pick-ups, calorimetry etc. for electron cloud characterisation
- Liners can be modified : Cu, NEG, a-C coating, Laser Engineered Samples etc.







Heat load



Electron collection

COLDEX: A Bench to Study Electron Cloud

- A system to simulate a LHC type vacuum system: perforated beam screen with cold bore
- BS ~ 5 to 100 K, CB ~ 3 to 5 K
- Pressure measurement, gas composition, calorimetric measurement, current measurement





How LESS surfaces are behaving?

57

Lecture 5 summary

- The vacuum life time is an accelerator is driven by elastic & inelastic interactions
- Accelerator vacuum systems can be modeled by simple sets of equations
- Accurate pressure profiles can be computed
- Accelerators operate as designed but there is always room for mistakes!
- Smart solutions have to be developed for specific issues
- Laboratory studies are needed to properly design a machine

WE NEED YOU!

Some References

- Cern Accelerator School, Vacuum technology, CERN 99-05
- Cern Accelerator School, Vacuum in accelerators, CERN 2007-03
- Vacuum system design, A.G. Mathewson, CERN-94-01
- The physical basis of ultra-high vacuum, P.A. Redhead, J.P. Hobson, E.V. Kornelsen. AVS.
- Scientific foundations of vacuum technique, S. Dushman, J.M Lafferty. J. Wiley & sons. Elsevier Science.
- Vacuum Technology, A. Roth. Elsevier Science
- Handbook of accelerator physics and engineering, World Scientific, 2013
- Accelerators and Colliders, Springer, 2013
- Design and modelling of UHV systems of particle accelerators, Wiley, 2019

Some Journals Related to Vacuum Technology and Accelerators

- Journal of Vacuum Science and Technology
- Vacuum
- Applied Surface Science
- Nuclear Instruments and Methods in Physics Research
- Physical Review Accelerators and Beams



Thank you for your attention !!!





Complementary information

1. Beam-gas interactions

Proton storage ring

- A single Coulomb scattering event is due to the elastic scattering via electromagnetic forces of an incoming particle on a nuclei.
- Multiple Coulomb scattering is due to the successive events of small angle scattering which leads to the gradual blow up of the beam emittance, ε and thus its dimension transverse σ .

$$\sigma = \sigma_0 e^{-\frac{t}{\tau_m}}$$

• The multiple scattering characteristic time, τ_m , is directly proportional to the beam momentum

$$\tau_m[hour] = 1.13 \ 10^{22} \frac{\varepsilon}{G\langle\beta\rangle} \frac{p^2}{n} \propto \frac{p^2}{\gamma} \propto p$$

Gas	Mass	Gas Factor
H ₂	2	21.10
He	4	39.45
CH ₄	16	370.86
H ₂ O	18	593.10
CO	28	900.66
N ₂	28	884.60
O ₂	32	1144.00
Ar	40	2709.26
CO ₂	44	1472.66

•With:

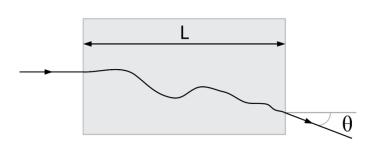
G the gas factor,

n the gas density (molecules/m³)

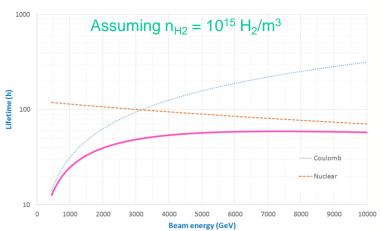
P the particle momentum (GeV/c)

<β> the average beta function (m)

 $\varepsilon = \varepsilon_0/\gamma$ the beam emittance (m rad)







The nuclear cross section dominates above 3 TeV



Electron storage ring

• The beam life time depends on 4 scattering cross sections

$$\sigma = \sigma_1 + \sigma_2 + \sigma_3 + \sigma_4$$

 $\tau = \frac{1}{n \sigma c}$

Nuclear elastic scattering:

$$\sigma_1 = 1.305 \ 10^{-35} \frac{Z^2}{E^2} \left[\left(\frac{\langle \beta_H \rangle}{a} \right)^2 + \left(\frac{\langle \beta_V \rangle}{b} \right)^2 \right]$$

Nuclear inelastic scattering:

$$\sigma_2 = 3.09 \ 10^{-31} \ Z^2 \ ln\left(\frac{183}{Z_3^{\frac{1}{3}}}\right) \left[ln\left(\frac{1}{X_{RF}}\right) - \frac{5}{8}\right]$$

\/\/ith:

 σi cross section in m^2

Z atomic number (i.e. 6 for C)

E the beam energy (GeV)

a semi-horizontal chamber dimension (m)

b semi-vertical chamber dimension (m)

<β> Average beta in H and V plane (m)

 $\varepsilon_{RF} = \chi_{RF} E$ is the maximum allowable energy spread in the RF ($\chi_{RF} <<1$)

Elastic scattering from electrons surrounding the nucleus of the residual gas:

$$\sigma_3 = 2.55 \ 10^{-32} \frac{Z}{X_{RF} E}$$

• Inelastic scattering from electrons surrounding the nucleus of the residual gas:

$$\sigma_4 = 3.09 \ 10^{-31} \ Z \left[ln \left(\frac{4.89 \ 10^3 \ E}{X_{RF}} \right) - 1.4 \right] \left[ln \left(\frac{1}{X_{RF}} \right) - \frac{5}{8} \right]$$



3. The LHC case

3.1 Design

LHC Current Parameters						
	Design		Commissioning			
	Nominal	Ultimate	2010	2011 (Fill 2256)	2012 (Fill 3250)	20 (Fill
	7	7	3.5	3.5	4	6
4-						

0.02

0.0

80

1.2

368

150

(75-50)*

~ 3

3.5

240

 $0.06 \ 10^{17}$

0.002

1 1021

3

0.36

5.9

362

1.45

1380

50

(25)*

~ 2.3

1

240

 $0.3 \ 10^{17}$

0.01

 $0.1\ 10^{24}$

314

5.5

0.75

23.3

420

1.6

1378

50

(25)*

~ 2.2

0.6

290

8.2

 $0.4 \ 10^{17}$

0.02

 $0.3 \ 10^{24}$

569

2.3

120

860

1.7

 $1.5 \ 10^{17}$

0.33

 $1.5 \ 10^{24}$

4100

1.0

80

584

1.15

2808

25

3.75

0.55

285

44.1

1 10¹⁷

0.22

1 1024

2800

Complementary information

2016

(Fill 5045)

6.5

1.0

16

447

1.19

2076

25

~ 3

0.4

185

35.3

 $0.8 \ 10^{17}$

0.13

 $0.2 \ 10^{24}$

255

2015

(Fill 4569)

6.5

0.6

4.2

468

1.15

2244

25

~ 3

8.0

290

35.3

 $0.8 \ 10^{17}$

0.13

 $0.1\ 10^{24}$

126

Energy [TeV]
Luminosity [v1034 cm-2 c-1]

Int. Luminosity [fb⁻¹/year]

Proton per bunch [x10¹¹]

Number of bunches

Bunch spacing [ns]

Normalised emittance

Critical energy [eV]

Photon flux [ph/m/s]

Photon dose [ph/m/year]

Beam dose per year [A.h]

SR power [W/m]

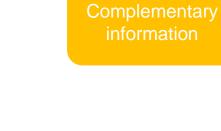
Total crossing angle [µrad]

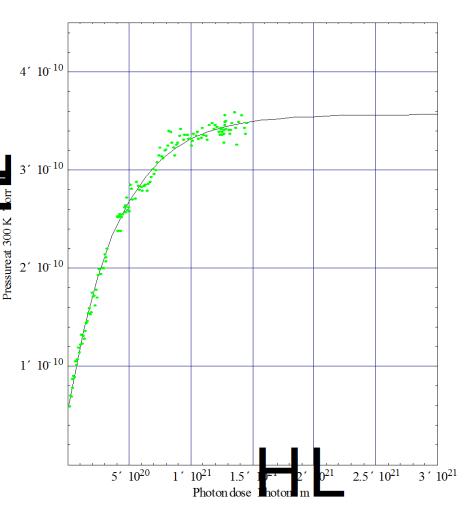
Current [mA]

[µm.rad]

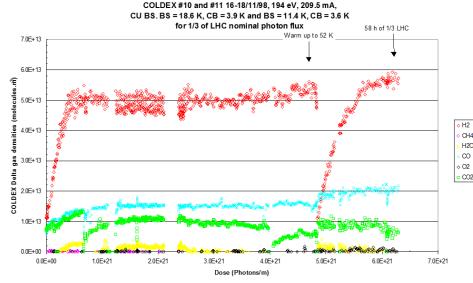
β * [m]

Fit to measured data at 10 K with 194 eV crit. energy





 $\eta = 2.6 \ 10^{-4} \ H_2/ph$ $\eta' = 0.08 \ H_2/ph/monolayer$ $\sigma = 0.08$





3.2 Arc Vacuum System

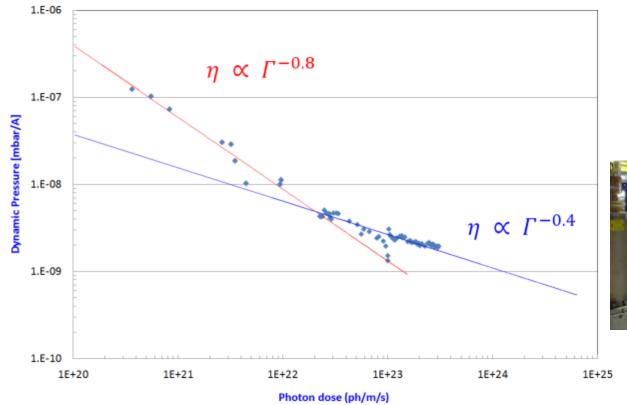
Arc: Some Numbers

Item	Total
Vacuum sectors (cryogenic)	16
Vacuum sector valves	32
Roughing valves (arc)	844
Ion pumps	0
Bayard Alpert gauges	0
Penning gauges (arc)	108
Pirani gauges	108

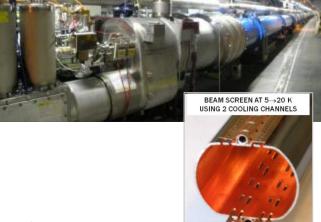
Item	Length (m)
Unbaked Arc @ cryo T	~ 45 000

Complementary information

- Arc extremity's vacuum gauges: unbaked Cu and cryogenic beam screen
- Reduction by 2 orders of magnitude since October 2010



- 2 trends:
- Room temperature
- Cryogenic temperature



- Inside the arc, at 5-20 K, $\Box P < 10^{-10}$ mbar (i.e. below detection limit)
- The photodesorption yield at cryogenic temperature is estimated to be < 10⁻⁴ molecules/photon

3.3 RT Vacuum System

LSS: Some Numbers

Component	Total
Vacuum sectors (cryogenic / RT)	84 / 185
Vacuum sector valves (all LHC)	295
Roughing valves (LSS)	309
lon pumps (special /30 / 60 / 400 l/s)	12 / 550/ 168 / 49
Bayard Alpert gauges (LSS)	178
Penning gauges (LSS)	502
Pirani gauges (LSS)	289

Item in LSS	Length (m)	% wrt to total
SAM @ cryo T	~ 1 365	19
LSS @ RT baked	~ 1 000	14
LSS @ RT with baked NEG	~ 4 800	67
Total length under vacuum	7 227	100

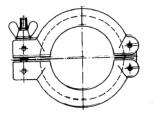
~ 85 % of the baked vacuum system is NEG coated

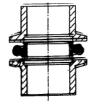


- For primary vacuum, elastomer seals and clamp flanges are used
- KF type components:

Many fittings (elbows, bellows, T, cross, flanges with short pipe, reductions, blank flanges ...)

ISO diameters





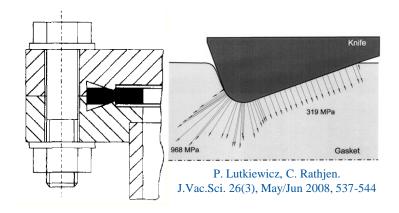


- For ultra high vacuum, metalic gaskets and bolds flanges are used
- Conflat® Type components :

Copper gaskets, blank flanges, rotable flanges, welding flanges, elbows, T, crosses, adaptators, zero length double side flanges, windows ...

ISO diameters





Tubes, Bellows, Valves

Complementary information

- Metallic tubes are preferred (low outgassing rate)
- Stainless steel is appreciated for mechanical reason (machining, welding)



Bellows are equipped with RF fingers (impedance)

Copper tubes





Valves are used for roughing and sectorisation

ion



Sector valves

Roughing valve



- The vacuum system of an accelerator must be leak tight!
- All vacuum components must follow acceptance tests (leak detection, bake out, residual gas composition and outgassing rate) before installation in the tunnel
- Virtual leaks, due to a closed volume, must be eliminated during the design phase. Diagnostic can be made with a RGA by measuring the gas composition before and after venting with argon.
- As a result of virtual leaks, the leak detection sensitivity limit in the concerned vacuum sector is altered
- Leaks could appear :
 - during components constructions at welds (cracks or porosity)
 - due to porosity of the material
 - during the assembly and the bake-out of the vacuum system (gaskets)
 - during beam operation due to thermal heating or corrosion



LSS Coating System

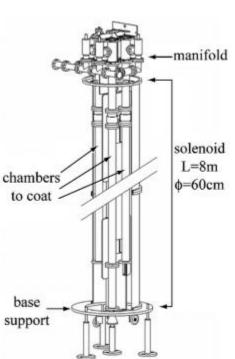
Complementary information

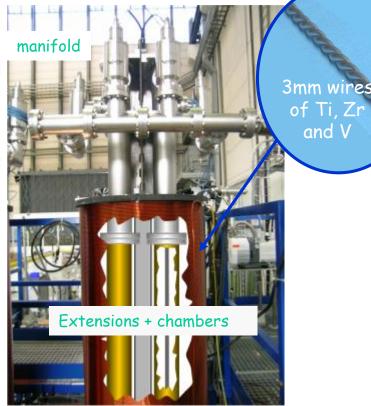
and V

- Ti-Zr-V is coated by magnetron sputtering with Kr gas
- ~ 1 µm thick
- All room temperature vacuum chamber including the experimental beam pipe are coated with Ti-Zr-V

Performances are valided by XPS on witness sample







P. Costa Pinto, P. Chiggiato / Thin Solid Films 515 (2006) 382-388



TiZrV Vacuum Performances

Complementary information

- Very low stimulated desorption yield
- SEY ~ 1.1 => very low multipacting
- But: limited capacity and fragile coating sensitive to pollutant (hydrocarbons, Fluor ...)

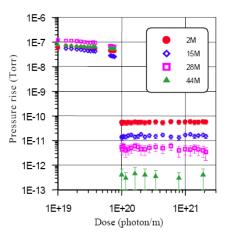


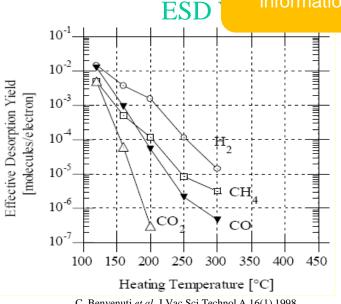
Figure 2: Pressure rise measured in the centre of the TiZrV coated test chamber before activation (<1.10²⁰ photons/m) and after activation (>1·10²⁰ photons/m).

PSD Yields

Table 2: Summary of results from the activated test chamber

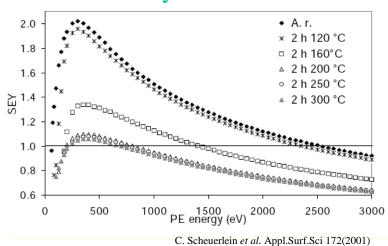
Gas	Sticking probability	Photodesorption yield (molecules/photon)	
H ₂	~0.007	~1.5·10 ⁻⁵	
CH ₄	0	2·10 ⁻⁷	
CO (28)	0.5	<1.10-5	
$C_xH_y(28)$	0	<3·10 ⁻⁸	
CO ₂	0.5	<2·10 ⁻⁶	

V. Anashin et al. EPAC 2002



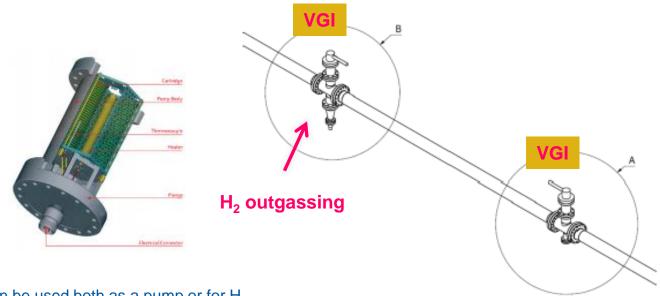
C. Benvenuti et al. J.Vac.Sci.Technol A 16(1) 1998

Secondary Electron Yield



4. Some studies related to LHC, HL-LHC, FCC etc. Vacuum systems

- •Three NEG pilot sectors with 2 modules each:
 - A6L8.R&B located in a full NEG coated sector
 - A5L2.R&B located beside a collimator
 - IP7.R&B located beside a sector valve

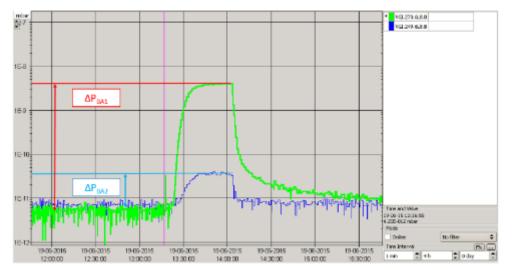


NEG cartridge: can be used both as a pump or for H₂ injections (thermal outgassing).

Figure 1: Pilot sector schematic

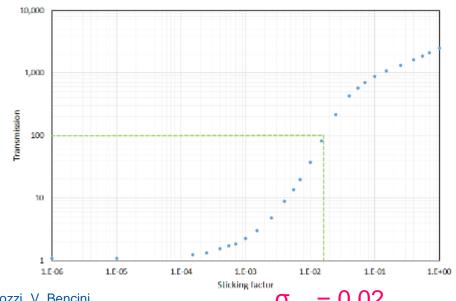
Monitor and qualify the ageing of NEG coatings due to the circulating beam

Complementary information



- H₂ injections are performed remotely
- The amount of injected gas is proportional to the current flowing in the NEG cartridge
- Injections are performed during LHC Technical Stop

- Pressure ratio i.e. transmission give the sticking factor
- Transmission are computed by monte carlo



Courtesy G. Bregliozzi, V. Bencini

 $\sigma_{H_2} = 0.02$